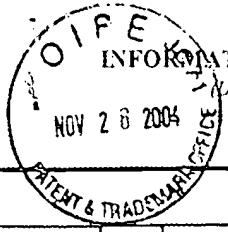


EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<p style="text-align: center;"> INFORMATION DISCLOSURE CITATION <small>(Use several sheets if necessary)</small> NOV 26 2004  </p>				Docket Number (Optional) YKI-0078		Application Number 09/966,692	
				Applicant(s) Yamada et al.			
				Filing Date 09/28/2001		Group Art Unit 2812	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>Sil</i>		6,373,187	04/16/2002	Nagayama et al.			
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EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS							
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation
							YES
<i>Sil</i>		JP 10-321372	1998.12.04	Japan			
<i>Sil</i>		JP 2000-200680	2000.07.18	Japan			
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
		Office Action for Korean Patent Application No. 10-2001-0059939 dated October 28, 2003					
EXAMINER <i>S. Silpuri</i>				DATE CONSIDERED <i>12/23/04</i>			
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